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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicants:	Justin K. Brask et al.	§	Art Unit:	2812
		§		
Serial No.:	10/805,798	§	Examiner:	Olivia T. Luk
		§		
Filed:	March 22, 2004	§	Docket No.	ITL.0894D1US (P15193)
		§		
Title:	Etching Metal Using Sonication	§	Assignee:	Intel Corporation
		§		

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

REPLY TO OFFICE ACTION DATED DECEMBER 2, 2004

Dear Sir:

Please amend the Abstract in accordance with the following SPECIFICATION  
AMENDMENTS section; and consider the comments in the following REMARKS section.

Date of Deposit: March 2, 2005  
I hereby certify under 37 CFR 1.8(a) that this correspondence is  
being deposited with the United States Postal Service as **first class**  
**mail** with sufficient postage on the date indicated above and is  
addressed to Mail Stop Amendment, Commissioner for Patents, P.O.  
Box 1450, Alexandria, Virginia 22313-1450.  
*Janice Munoz*  
Janice Munoz